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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

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		)	Art Unit (not assigned)
Application No.:	(not assigned)	)	
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Filed:	(not assigned)	)	PCT/JP2004/016839
		)	
For:	VACUUM EVAPORATION DEPOSITION	)	
	METHOD OF THE WINDING TYPE AND	)	
	VACUUM EVAPORATION DEPOSITION	)	
	APPARATUS OF THE SAME	)	
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**PRELIMINARY AMENDMENT**

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Sir:

Kindly enter the following preliminary amendments to the claims, specification, abstract  
and drawings as indicated hereinafter.